



03500.014241

*#10/Election*  
*8/22/03*  
*C Moore*

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Examiner: J. Williams  
NOBUHIRO ITO ) Group Art Unit: 2879  
Application No.: 09/505,627 )  
Filed: February 16, 2000 )  
For: MANUFACTURING METHOD OF )  
ELECTRON BEAM APPARATUS )  
AND SPACER, AND ELECTRON )  
BEAM APPARATUS ) August 6, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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TC 2800 MAIL ROOM

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This is in response to the Office Action dated July 29, 2003, imposing a restriction requirement in the above-identified application.

REMARKS

The Examiner has required election of a single disclosed invention for prosecution on the merits in this case. The Examiner alleged the existence of two patentably distinct inventions:

Group I: Claims 1-50, drawn to a method, drawn to a method of making an electron apparatus, classified in class 427, subclass 58; and

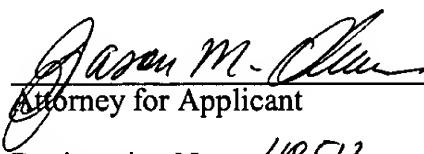
Group II: Claims 51-56, drawn to an electron apparatus, classified in class 313, subclass 495.

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Applicant hereby provisionally elects Group I, claims 1-50, with traverse.

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
\_\_\_\_\_  
Attorney for Applicant

Registration No. 48,512  
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